IN THE UNITED STATE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: D. Kang

Art Unit: 2811

n re application of:

Min-hwa Chi

Application No: 09/865,929

Filed: May 24, 2001

For: TRANSISTOR AND LOGIC CIRCUIT

ON THIN SILICON-ON-INSULATOR WAFERS BASED ON GATE INDUCED

LEAKAGE CURRENTS

Box Non-Fee Amendment Honorable Commissioner for Patents Washington, D.C. 20231

PRELIMINARY AMENDMENT UNDER 37 CFR §1.115 AND 1.121

Sir:

In response to the Notice of Allowability mailed January 15, 2003, the Applicant submits the following Remarks. The Applicants respectfully request that the Examiner enter the Amendment and consider the Remarks.

It is not believed that extensions of time are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefore are hereby authorized to be charged to Deposit Account No. 02-2666. Please credit any overpayment to the same deposit account.

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Kindly consider the following Remarks.

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Atty. Docket No.: 004192.P053D

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